Patent Atty. Docket: H60-099 US #3

7/9/02

CERTIFICATE OF MAILING

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Annita Lise Dated:

V-1602

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant

Hans Martin BUSCHBECK, et al

Serial No.

09/975,885

Filing Date

October 12, 2001

Examiner

N/A

Group Art Unit

N/A

For

METHOD FOR PRODUCING COMPONENTS

AND ULTRAHIGH VACUUM CVD REACTOR

Box Missing Parts Commissioner for Patents Washington, D.C. 20231

PRELIMINARY AMENDMENT

Sir:

Prior to examination, please amend the above-identified application, as follows:

IN THE ABSTRACT:

Please add an Abstract of the Disclosure, as set out on the attached separate sheet.

IN THE CLAIMS

Please cancel Claims 1-48.

Please add the following new Claims 49-96: